

RCE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Application No.: 10/589,962

Filed: August 18, 2006

For: EXPOSURE METHOD, EXPOSURE
APPARATUS, EXPOSURE SYSTEM AND
DEVICE MANUFACTURING METHOD



Group Art Unit: 2882

Examiner: C. RIDDLE

Docket No.: 128675

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

☒ Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 233433 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,


Mario A. Costantino
Registration No. 33,565

Steven D. Jinks
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MAC:SDJ/cfr

Date: November 16, 2010

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**DEPOSIT ACCOUNT USE
AUTHORIZATION**

Please grant any extension
necessary for entry of this filing;
Charge any fee due to our
Deposit Account No. 15-0461